

IPWS

Docket No.: 67161-067

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Kiyoshi MAESHIMA : Confirmation Number: 9719
Serial No.: 10/620,367 : Group Art Unit: 1756
Filed: July 17, 2003 : Examiner:

For: PHOTO MASK, METHOD OF MANUFACTURING ELECTRONIC DEVICE, AND METHOD OF
MANUFACTURING PHOTO MASK

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

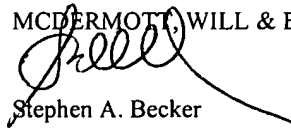
Upon review of the PTO-Form 1449 filed on March 9, 2004, the client has noted an inverted error in one of the references. It is respectfully requested that the revised Form 1449 herein be considered. The references listed have already been submitted to the PTO.

This Supplemental Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Respectfully submitted,

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SHEET 1 OF 1

SUPPLEMENTAL INFORMATION
DISCLOSURE CITATION IN AN
APPLICATION

(PTO-1449)

ATTY. DOCKET NO.
67161-067SERIAL NO.
10/620,367APPLICANT
Kiyoshi MAESHIMAFILING DATE
July 17, 2003GROUP
1756

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US 5,888,674	03/30/1999	Yang et al.	
		US			
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes - Number - Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
*		JP 2001-312043 A	11/09/2001	DAINIPPON PRINTING CO LTD		JAPAN (w/English Abstract)	
*		JP 2000-127548	04/27/2000	-			x
✓		Taiwanese Patent No. 479155	03/11/2002	-			X

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.
Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

* Did not Receive them.